



**ELECTRONIC COPY**

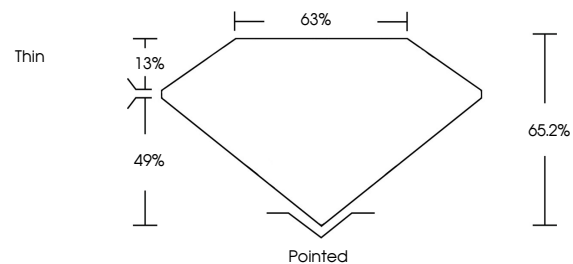
LG778683594  
Report verification at [igi.org](http://igi.org)



March 9, 2026  
IGI Report Number **LG778683594**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **15.92 X 10.57 X 6.89 MM**  
**GRADING RESULTS**  
Carat Weight **9.81 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

March 9, 2026  
IGI Report Number **LG778683594**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **15.92 X 10.57 X 6.89 MM**

**PROPORTIONS**

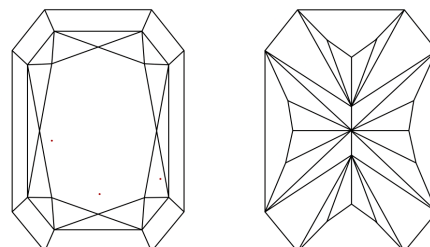


Sample Image Used

**GRADING RESULTS**

Carat Weight **9.81 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**  
Cut Grade **EXCELLENT**

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778683594**

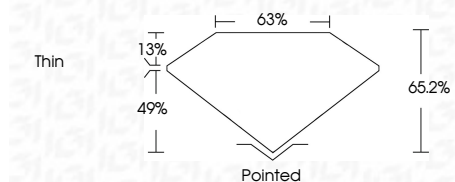
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778683594**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



March 9, 2026  
IGI Report No LG778683594  
CUT CORNERED RECT. MODIFIED BRILLIANT  
15.92 X 10.57 X 6.89 MM  
9.81 CARATS  
F  
VVS 2  
EXCELLENT  
66.2%  
68%  
Thin  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG778683594  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa